

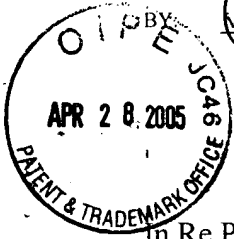
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IFW \$

Renée Conti

Date:

April 25, 2005



MAIL STOP AMENDMENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:
Tuung Luoh

Conf. No.:	5065	:	Group Art Unit:	2818
Appln. No.:	10/715,558	:	Examiner:	Phuc T. Dang
Filing Date:	November 19, 2003	:	Attorney Docket No.:	681939-44US
Title:	METHOD OF FORMING A POLYSILICON LAYER COMPRISING MICROCRYSTALLINE GRAINS			

AMENDMENT

This is in response to the Office Action dated December 23, 2004 (Paper No. 1204) in the above-identified patent application. This response is being timely filed by April 25, 2005 (April 23 being a Saturday) in view of the accompanying Petition for Extension of Time (one month). Please amend the application, without prejudice, as follows: